



Subt. For, PTO-1449		Docket Number 114096.121 US2	Application Number 10/765,368
INFORMATION DISCLOSURE IN AN APPLICATION		Applicant Henry A. Hill	
(Use several sheets if necessary)		Filing Date January 27, 2004	Group Art Unit 2877 2873
Sheet	1	OF	3

U.S. Patent Documents				
Examiner Initial	Document Number	Pubin. Date mm-dd-yyyy	Name Of Patentee Or Applicant Of Cited Documents	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear
J-F.	09/852,369	01/03/02	Hill	
	09/917,402	07/27/01	Hill	
	10/765,368	01/27/04	Hill	
	3,628,027	12/14/71	Brauss	
	3,748,015	07/24/73	Offner	
	4,011,011	03/08/77	Hemstreet et al.	
	4,226,501	10/07/80	Shafer	
	4,272,684	06/09/81	Seachman	
	4,685,803	08/11/87	Sommargren	
	4,733,967	03/29/88	Sommargren	
	5,220,403	09/30/02	Batchelder	
	5,241,423	08/31/93	Chiu et al.	
	5,327,223	07/05/94	Korth	
	5,485,317	10/08/93	Perissinotto	
	5,602,643	02/07/96	Barrett	
	5,614,763	03/13/95	Womack	
	5,633,972	11/29/95	Walt	
	5,659,420	08/19/1997	Wakal	
	5,699,201	03/27/95	Lee	
	5,760,901	01/28/97	Hill	
	5,828,455	10/27/98	Smith	
	5,894,195	05/03/96	McDermott	
	5,915,048	06/05/96	Hill, et al.	
	6,052,231	04/18/00	Rosenbluth	
	6,091,496	06/02/98	Hill	
	6,124,931	09/26/00	Hill	
	6,271,923	08/07/01	Hill	
	6,330,065	04/28/99	Hill	
	6,445,453	08/02/00	Hill	
	6,447,122	09/10/02	Kobayashi et al.	
	6,480,285	03/16/00	Hill	
J-F.	6,552,805	07/27/01	Hill	

EXAMINER	DATE CONSIDERED
5/4/06	
EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP § 609: Draw Line through citation if not conformance and not considered. Include copy with next communication to applicant.	

Sub. For, PTO-1449

INFORMATION DISCLOSURE
IN AN APPLICATION

(Use several sheets if necessary)

Sheet

2

OF

3

Docket Number
114096.121 US2Application Number
10/765,368Applicant
Henry A. Hill

Filing Date

Group Art Unit

January 27, 2004

2877 28

J-F.	6,552,852	12/20/01	Hill	
	6,597,721	07/22/03	Hutchinson et al.	
	6,606,159	08/02/00	Hill	
	6,667,809	07/27/01	Hill	
	6,714,349	03/25/02	Nam	
	6,717,736	07/13/03	Hill	
	6,753,968	01/30/03	Hill	
	6,775,009	07/27/01	Hill	
	6,847,029	07/27/01	Hill	
	6,847,452	03/20/03	Hill	
	60/442,858	07/27/02	Hill	
	60/442,982	01/29/03	Hill	
	60/444,707	01/04/03	Hill	
	60/445,739	02/07/03	Hill	
	60/447,254	02/13/03	Hill	
	60/459,425	04/11/03	Hill	
	60/460,129	04/03/03	Hill	
	US2002/0074493	07/27/01	Hill	
	US2003/0174992	09/18/03	Levene	
	US2004/0201852	02/04/04	Hill	
	US2004/0201853	02/13/04	Hill	
	US2004/0201854	02/19/04	Hill	
	US2004/0201855	02/19/04	Hill	
	US2004/0202426	02/06/04	Hill	
	US2004/0227950	04/01/04	Hill	
	US2004/0227951	04/04/04	Hill	
	US2004/0228008	04/04/04	Hill	
	US2004/0246486	01/27/04	Hill	
J-F.	US2004/0257577	01/27/04	Hill	

Foreign Patent Documents

Examiner Initial	Cite No.	Foreign Patent Document	Publn. Date mm-dd-yyyy	Country	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear
		Country Code-Number- Kind			

EXAMINER

DATE CONSIDERED

5/4/06

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP § 609: Draw Line through citation if not conformance and not considered. Include copy with next communication to applicant.

Sub. For, PTO-1449				Docket Number 114096.121 US2	Application Number 10/765,368
INFORMATION DISCLOSURE IN AN APPLICATION <i>(Use several sheets if necessary)</i>				Applicant Henry A. Hill	
Sheet	3	OF	3	Filing Date January 27, 2004	Group Art Unit 2877 2873

Examiner's Initial	Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)		
J-F.	AA	Silfvast, W. (1995) "Lasers", <i>Handbook of Optics</i> , New York: McGraw-Hill, Ch. 11	
	AB	Stoicheff, et al. "Tunable, Coherent Sources for High Resolution VUV and XUV Spectroscopy", <i>Laser Techniques for Extreme Ultraviolet Spectroscopy</i> , P. 19 (1982)	
	AC	Harris, et al. "Generation of Ultraviolet and Vacuum Ultraviolet Radiation" <i>Laser Spectroscopy</i>	
	AD	Kung, A.H., "Generation of Tunable Picosecond VUV Radiation" <i>Appl. Phys Lett.</i> 25, p. 653 (1974)	
J-F.	AE	D'ariano, et al. "Lower Bounds on Phase Sensitivity in Ideal and Feasible Measurements" <i>Phys. Rev. A</i> 49, pp. 3022-3036 (1994)	

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP § 609: Draw Line through citation if not conformance and not considered. Include copy with next communication to applicant.	